

10/529152

JC06 Rec'd PCT/PTO 24 MAR 2005

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q87054

Yasuki KIMURA

Appln. No.: National Stage Entry of PCT/JP2004/004938      Group Art Unit: Not Yet Assigned

Confirmation No.: Not Yet Assigned

Examiner: Not Yet Assigned

Filed: March 24, 2005

For:    METHOD OF ETCHING A CHROMIUM-BASED THIN FILM AND METHOD OF  
         MANUFACTURING A PHOTOMASK

**PRELIMINARY AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the  
accompanying pages.

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